PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
TOSHIHISA OZU	05/14/2014
NAOKI MATSUMOTO	05/12/2014
TAKASHI TSUKAMOTO	05/20/2014
KAZUTO TAKAI	05/12/2014

RECEIVING PARTY DATA

Name:	TOKYO ELECTRON LIMITED
Street Address:	3-1, AKASAKA 5-CHOME, MINATO-KU
City:	TOKYO
State/Country:	JAPAN
Postal Code:	107-6325

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14287537

CORRESPONDENCE DATA

Fax Number: (860)286-0115

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 860-286-2929

Email: usptopatentmail@cantorcolburn.com

Correspondent Name: CANTOR COLBURN LLP Address Line 1: 20 CHURCH STREET

Address Line 2: 22ND FLOOR

Address Line 4: HARTFORD, CONNECTICUT 06103

ATTORNEY DOCKET NUMBER:	BPL0144USD
NAME OF SUBMITTER:	JAEGYOO JANG
SIGNATURE:	/Jaegyoo Jang/
DATE SIGNED:	05/27/2014
	This document serves as an Oath/Declaration (37 CFR 1.63).

Total Attachments: 6

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502824732 REEL: 032966 FRAME: 0220

PATENT



PATENT REEL: 032966 FRAME: 0221

DECLARATION AND ASSIGNMENT

Title of Invention: PLASMA PROCESSING APPARATUS AND PLASMA ETCHING APPARATUS

As a below named inventor, I hereby declare that:

This de	claration is directed to:
	[X] The attached application (Attorney Docket Number BPL0144USD), o
	[] United States application or PCT international application number filed on

The above-identified application was made or authorized to be made by me.

I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.

I have reviewed and understand the contents of the application, including the claims.

I am aware of the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in 37 CFR Section 1.56.

Whereas, each undersigned inventor has made certain inventions, improvements, and discoveries (herein referred to as the "INVENTION") disclosed in the above-identified patent application (herein referred to as the ("APPLICATION");

Whereas, TOKYO ELECTRON LIMITED, a corporation of Japan having a place of business at 3-1. Akasaka 5-chome, Minato-ku, Tokyo 107-6325, Japan (herein referred to as "ASSIGNEE"), desires to acquire, and each undersigned inventor desires to grant to ASSIGNEE, the entire worldwide right, title, and interest in and to the INVENTION and in and to any and all patent applications and patents directed thereto:

Now, therefore, for good and valuable consideration, the receipt and sufficiency thereof being bereby acknowledged, each undersigned inventor (herein referred to ASSIGNOR") hereby sells or has sold, assigns or has assigned, and otherwise transfers or has transferred to the ASSIGNEE, its successors, legal representatives, and assigns, the entire worldwide right, title, and interest in and to the INVENTION, the APPLICATION, and any and all other patent applications and patents for the INVENTION which may be applied for or granted therefor in the United States and in all foreign countries and jurisdictions, including all divisions, continuations, continuations-in-part, reissues, reexaminations, renewals, extensions, counterparts, substitutes, and extensions thereof, and all rights of priority resulting from the filing of such applications and granting of such patents. In addition, each undersigned inventor hereby authorizes and requests the Director of the United States Patent and Trademark Office to issue any United States Patent, and foreign patent authorities to issue any foreign patent, granted for the INVENTION, to ASSIGNEE, its successors, legal representatives, and assigns, the entire worldwide right, title, and interest in and to the same to be held and enjoyed by ASSIGNEE, its successors, legal representatives, and assigns to the full end of the terms for which any and all such patents may be granted, as fully and entirely as would have been held and enjoyed by the undersigned

had this Assignment not been made; and each undersigned inventor agrees to execute any and all documents and instruments and perform all lawful acts reasonably related to recording this Assignment or perfecting title to the INVENTION, the APPLICATION, and all related patents and applications, in ASSIGNEE, its successors, legal representatives, and assigns, whenever requested by ASSIGNEE, its successors, legal representatives, and assigns.

I hereby acknowledge that any willful false statement made in this declaration is punishable under18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.

Legat Name of I	nvemor: 108mmsa ULU		
Signature:	<u>John Liss</u>		Date: 2014 - 25 - 15
Legal Name of I	inventor: Naoki MATSUMOTO	3	
Signature:			Date:
Legal Name of I	inventor: Takashi TSUKAMOT	0	
Signature:			Date:
Legal Name of i	inventor: Kazuto TAKAI		
Sionature			Deje:

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Legal Name of Inventor: Toshibisa OZU	
Signature:	Date:
Legal Name of Inventor: Naoki MATSUMOTO	
Signature: <u>Navlai Instrumet</u>	Date:
Legal Name of Inventor: Takashi TSUKAMOTO	
Signature:	- Date:
Legal Name of Inventor: Kazuto TAKAI	
Signature: Ka290 Aka2	Date: 16912 - 3014

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Legal Name of Inventor: Toshihisa OZU	
Signature:	Date:
Legal Name of Inventor: Naoki MATSUMOTO	
Signature:	Date:
Legal Name of Inventor: Takashi TSUKAMOTO	
Signature: Taka shi Tsu ka mo to.	Date: 5/20/2014
Legal Name of Inventor: Kazuto TAKAI	
61	Data

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